



IPW

Docket No.: 60188-693

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Yoshiyuki SHIBATA : Confirmation Number: 4097  
Serial No.: 10/694,891 : Group Art Unit: 2812  
Filed: October 29, 2003 : Examiner: Jennifer M. KENNEDY  
For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of April 20, 2004 wherein restriction has been required, Applicant(s) hereby elect First Embodiment, Group I, corresponding to Figs. 2, 3A-3D and 4A-4B (claims 1-7, drawn to a semiconductor device) for prosecution in the above-identified application. Furthermore, Applicants identify claim 3 as reading on the elected species.

To the extent necessary, a petition for an extension of time under 37 C.F.R. § 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
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